

Development of “green” photocathode

■ Thesis status Updates

Sandeep Kumar Mohanty

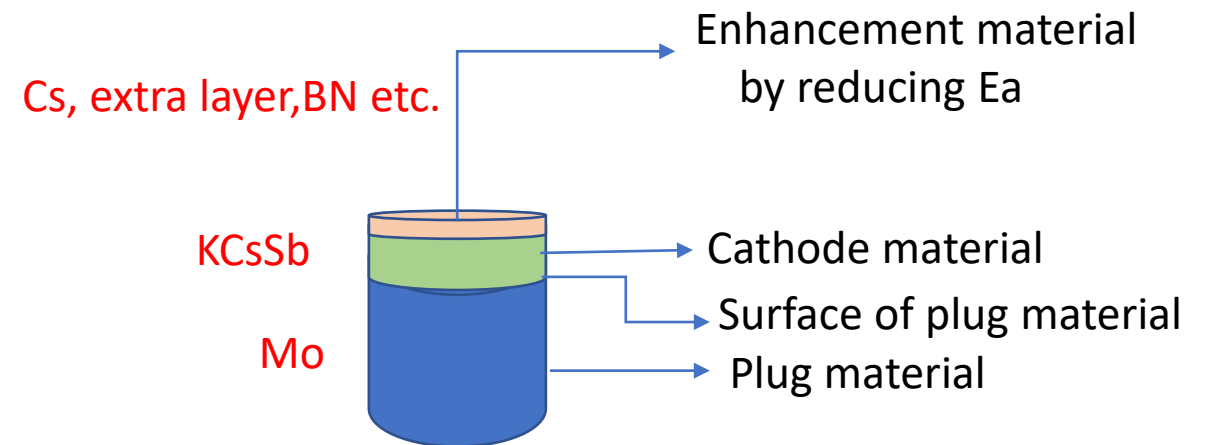
PPS

06.08.2020

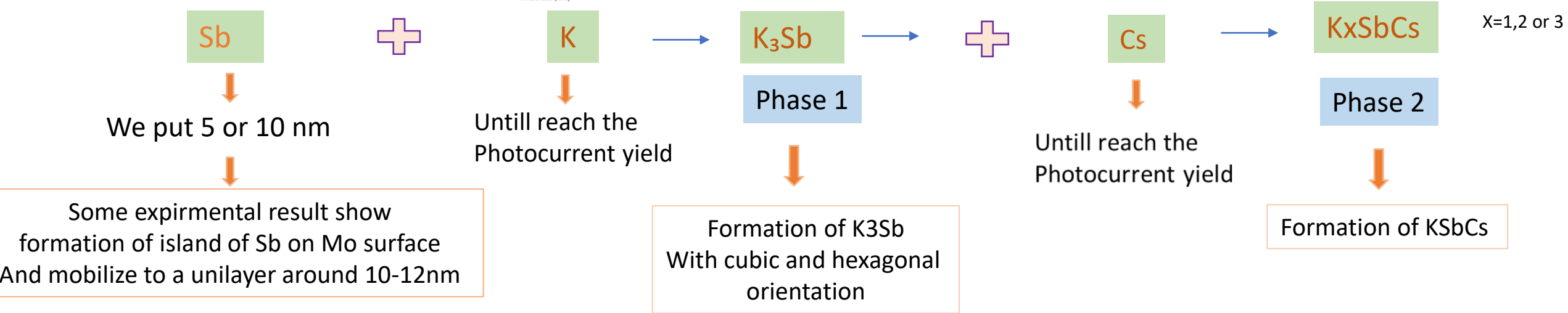
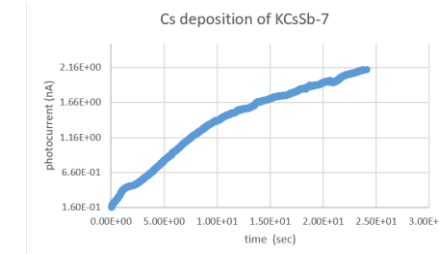
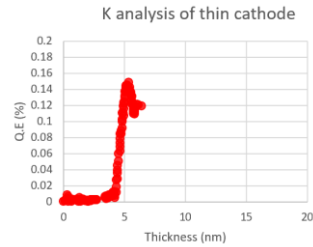
KSbCs Photocathode

Factors affecting on Photocathode properties

- **Plug material:** Conductivity, avoid diffusion of film material (Mo, Si, Steel)
- **Surface:** Cleanliness and flatness (thermal emittance, unwanted contaminants especially oxides)
- **Cathode material:** Stoichiometry , crystal structure and orientation
- **Enhancement material:** special material like BN, graphene etc., also layer up on layer, excess Cs



■ KCsSb sequential growth analysis

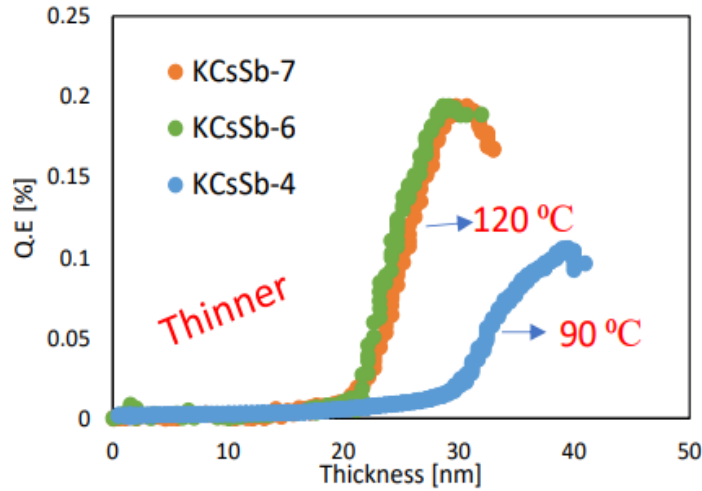


ref: C.Ghosh Journal of Applied Physics 49, 4549 (1978)
Also by Modena group

Ref: S.g Schubert Conference: 5th International Particle Accelerator Conference IPAC14

Sb 5nm = Thin
Sb 10 nm = Thick

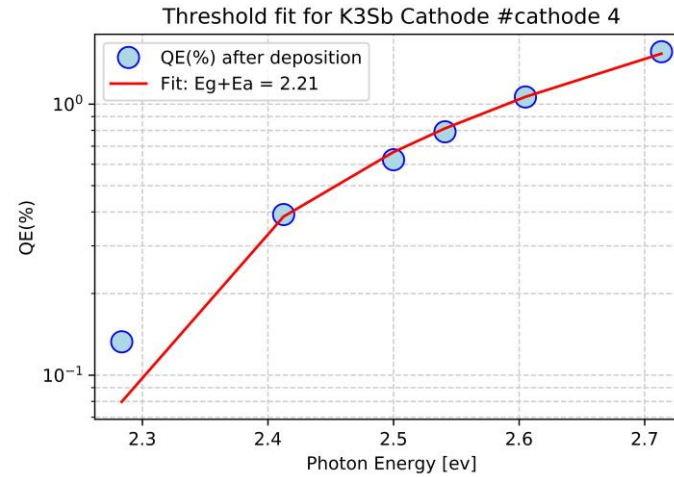
K₃Sb Phase



120°C : less amount require to reach threshold

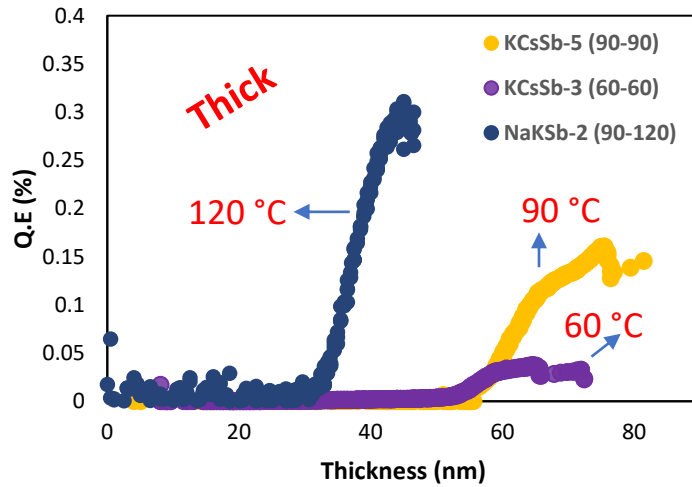
- Better Chemical reaction
- Better crystallinity with less defect

compare with spicer model



All the cathodes shows similar ($E_g + E_a$) value i.e, 2.2

$(E_g + E_a)_{th}$ for K₃Sb= 2.2



Formula spicer model: Y (threshold) = $A * [E - (E_g + E_a)^{1.5}] / [E - (E_g + E_a)^{1.5}] + B$
 Sandeep Mohanty | PITZ Physics seminar | Thesis update

Compare with BNL group data

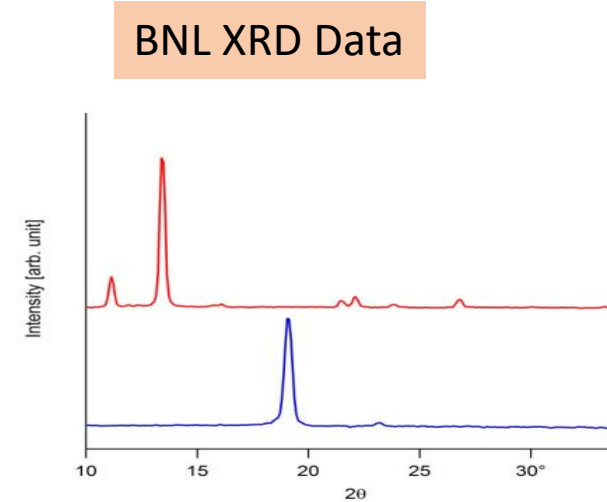
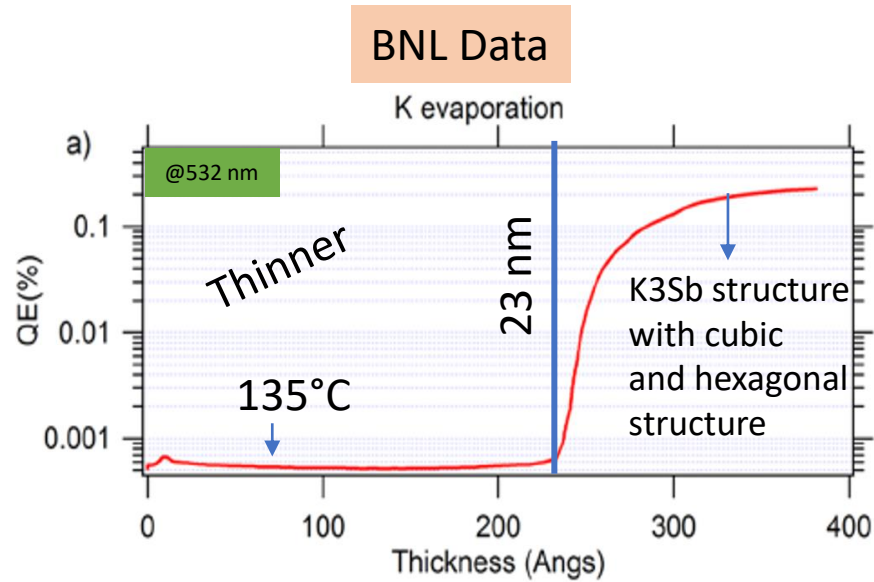
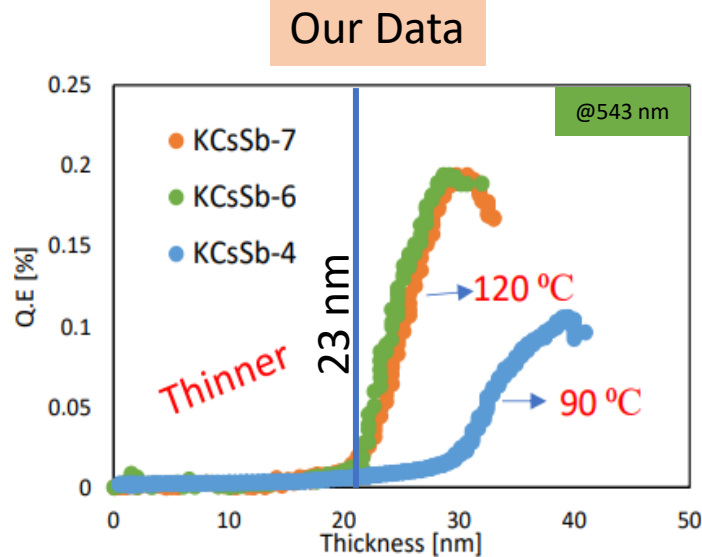


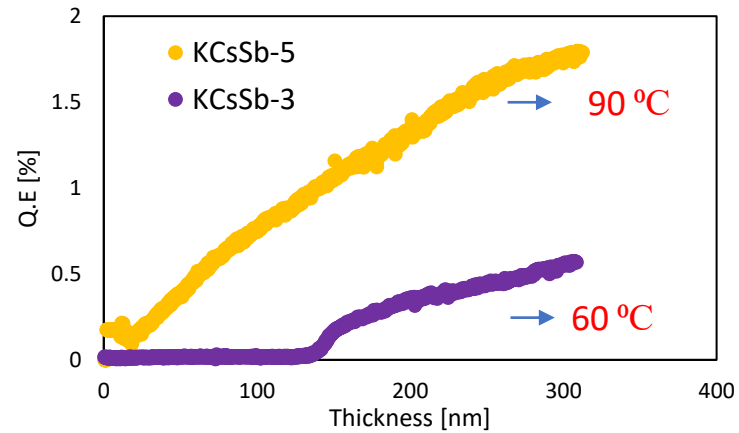
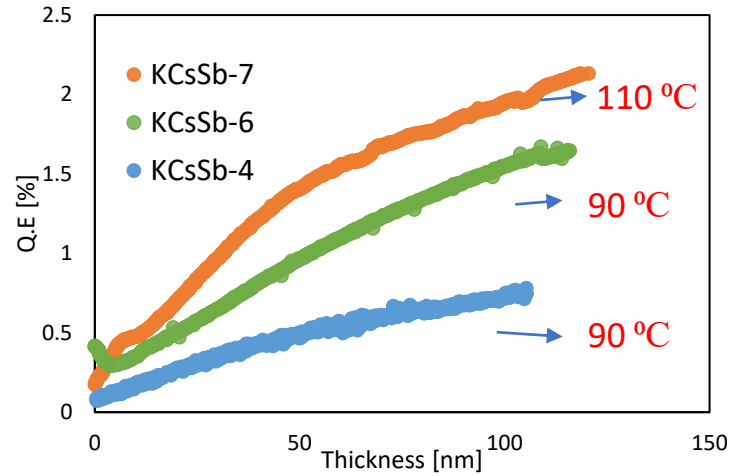
Figure 1: Sequential K_3Sb growth; blue - Sb layer and red - K_3Sb layer.

ref :APL Materials **2**, 121101 (2014); doi: 10.1063/1.4902544



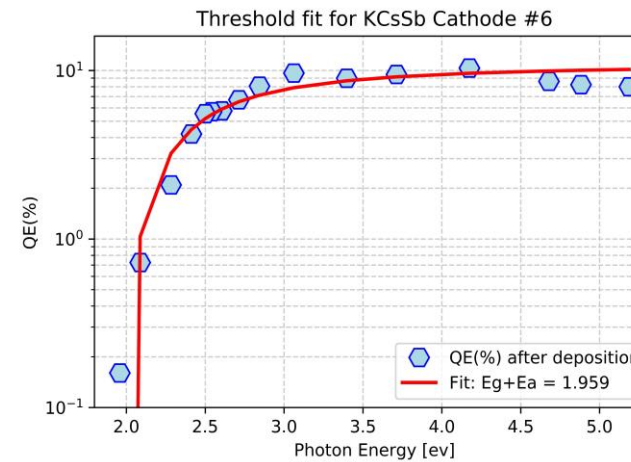
- Improve in Q.E relate to better crystal quality which will reduce impurity scattering.
- Probable similar crystal structure occurs during growth like BNL.
- Sofar we get 0.3% @543 nm during K_3Sb growth.
- But a detailed XPS or XRD study required.

KSbCs Phase



- High temperature gives better reaction rate and better crystallinity which leads to better Q.E.

compare with spicer model

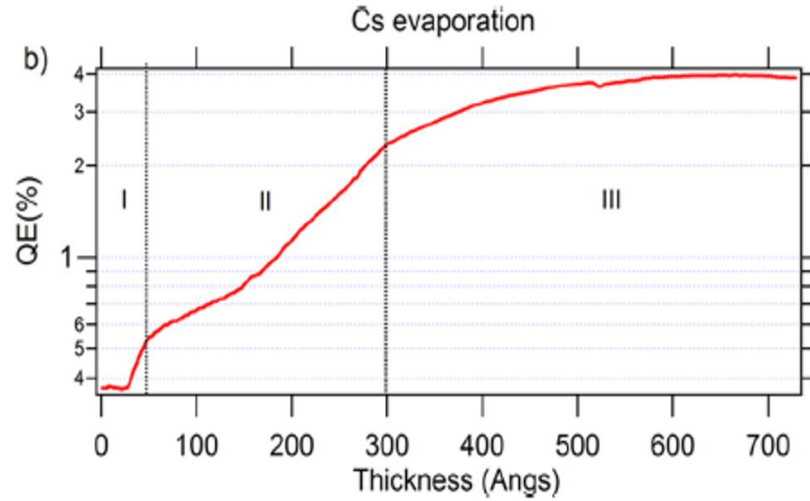


$(E_g + E_a)_{th}$ for KSbCs = 1.93

Formula spicer model: $Y(\text{threshold}) = A * [E - (E_g + E_a)^{1.5}] / [E - (E_g + E_a)^{1.5} + B]$

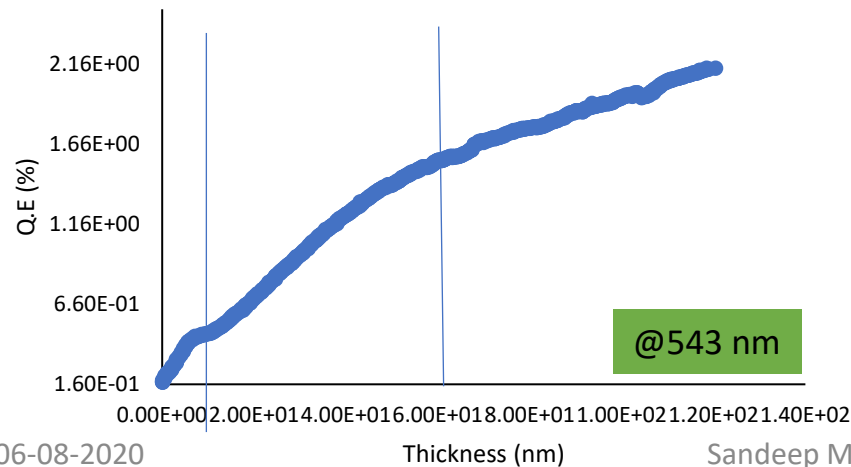
Compare with BNL group data

BNL Data



Our Data

Cs deposition of KCsSb-7



BNL XRD Data

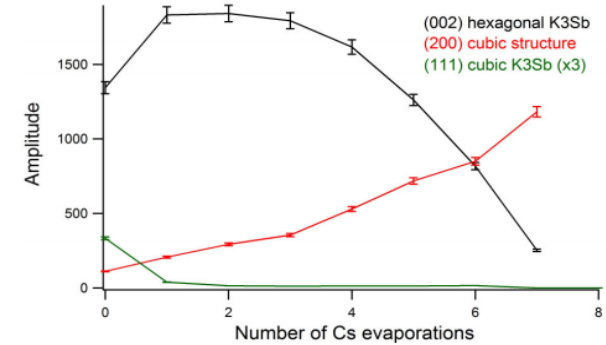
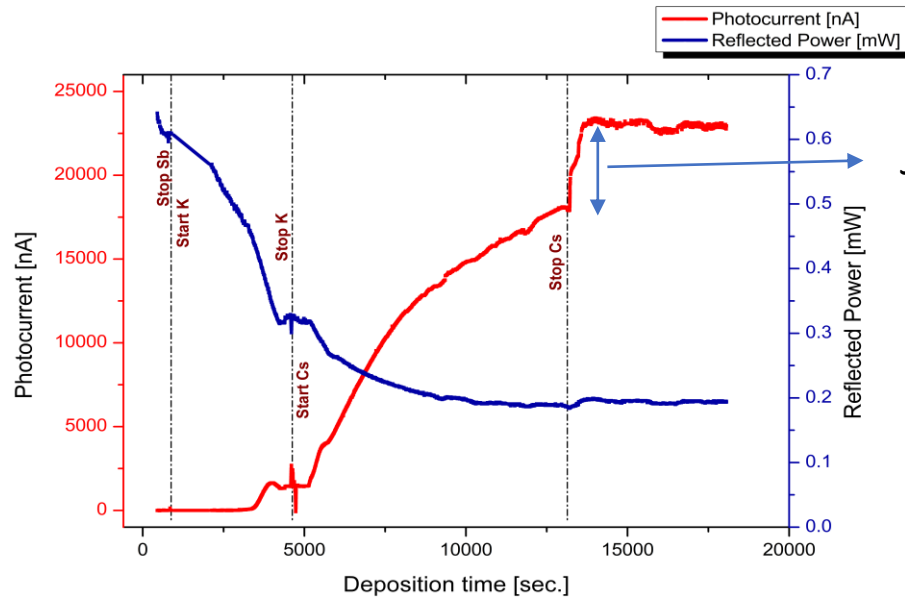


Figure 5: Change of amplitude of (111) cubic K₃Sb (green), (002) hexagonal K₃Sb (black) and (200) cubic CsK₂Sb Bragg peak upon Cs deposition onto K₃Sb cubic/ hexagonal mixture.

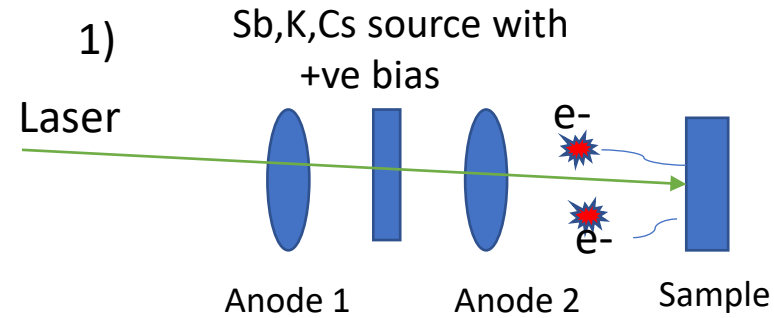
ref :APL Materials **2**, 121101 (2014); doi: 10.1063/1.4902544

- Cs can better react with cubic type of K₃Sb structure.
- Reaction between Cubic type K₃Sb with Cs will lead to a better Q.E of final cathode.

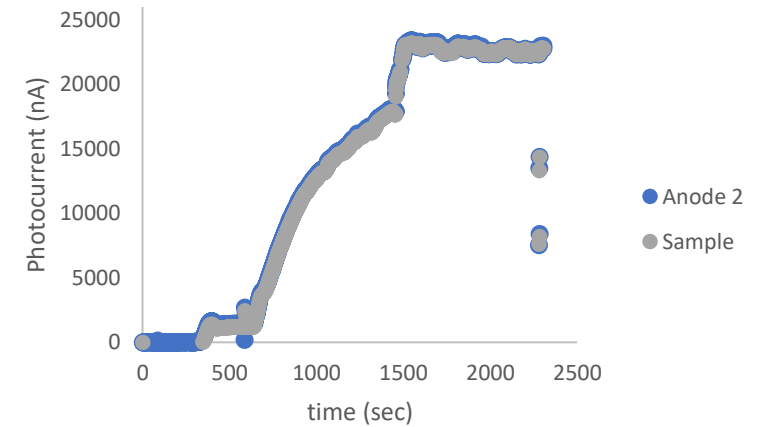
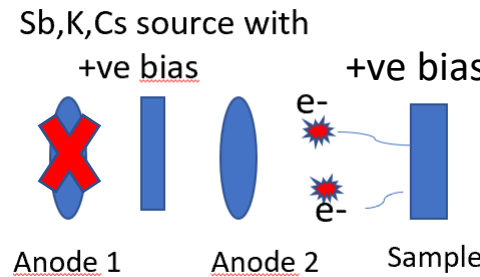
Cs Jump analysis



Jump?

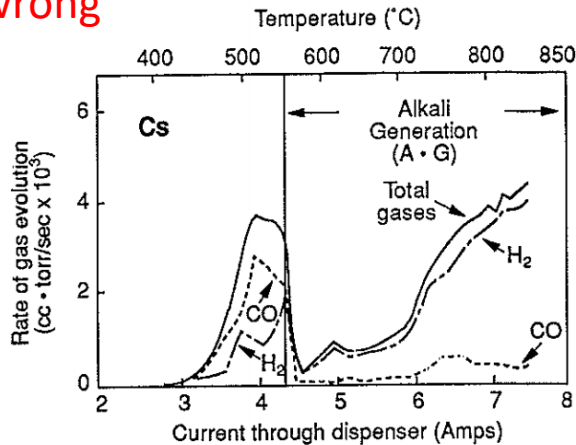


Wrong

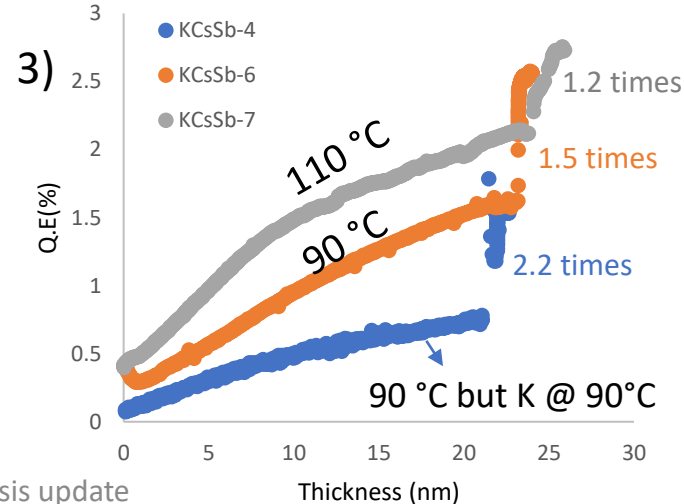


Partial wrong

2)



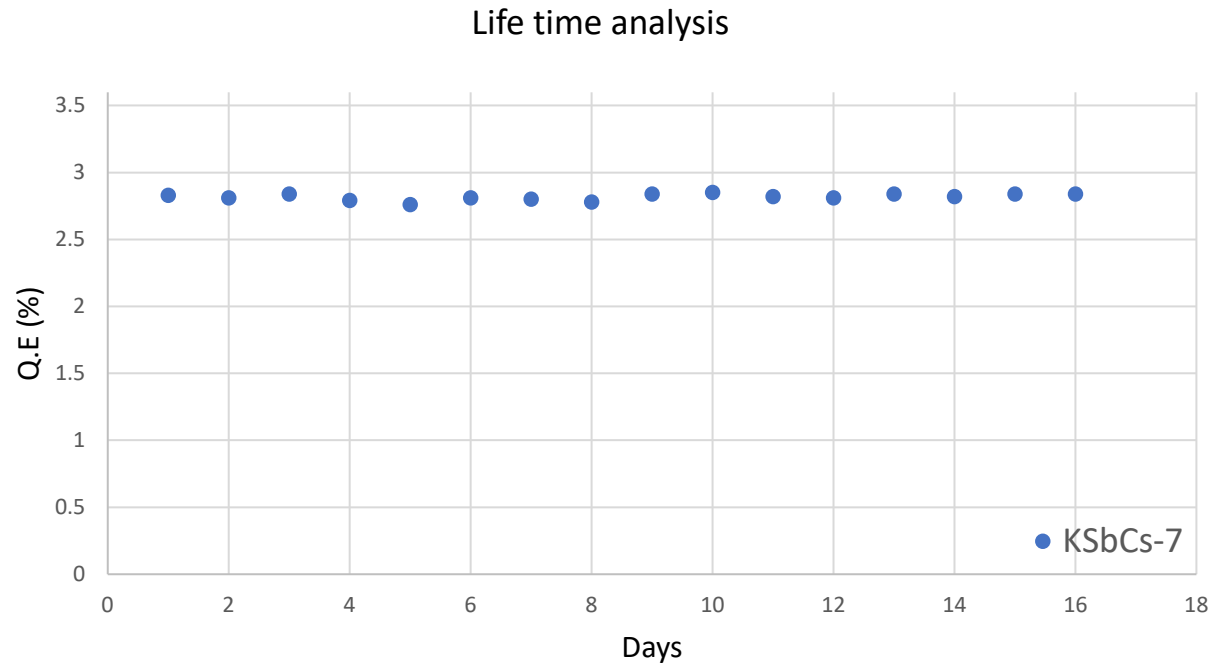
Jump analysis of thin cathode



Temperature dependance and Relate to the Cs reaction

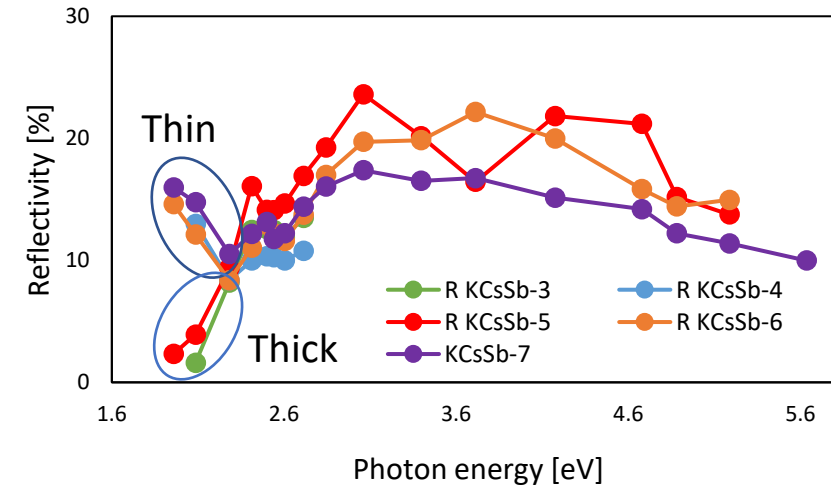
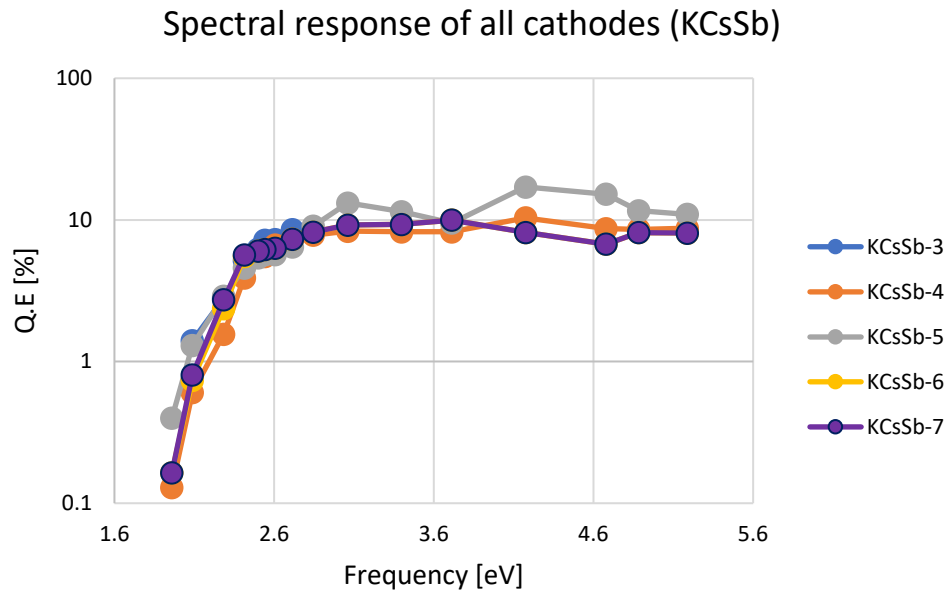
- Either increase T
- Or decrease rate of deposition

Life time



Laser power : 2 mw of 543nm
Avg. Photocurrent : 23 micro amp
Avg. Q.E: 2.8% @543 nm

Ratio, Q.E, Reflectivity



- 5.7% Q.E @514 nm is achieved from cathode 7 with 17% yield @297 nm

Thin Cathode

Cathodes	Sb[nm]	K [nm]	Cs[nm]	Q.E.(%)@514nm
KCsSb-7 [90-120-110]	5	34	121	5.7
KCsSb-6 [90-120-90]	5	32	117	5.2
KCsSb-4 [90-90-90]	5	41	106	4.2
Ratio	1	: ~(7-8)	: ~23	

Thick Cathode

Cathodes	Sb[nm]	K [nm]	Cs[nm]	Q.E.(%)@514nm
KCsSb-5 [90-90-90]	10	75	316	5.2
KCsSb-3 [60-60-90]	10	66	313	5.2
Ratio	1	: ~7	: ~31	

Q.E is Independent of cathode thickness
But thin cathode can give low surface roughness

NaKSb (Cs)

- Motivation: higher stability in higher temperature and high Q.E

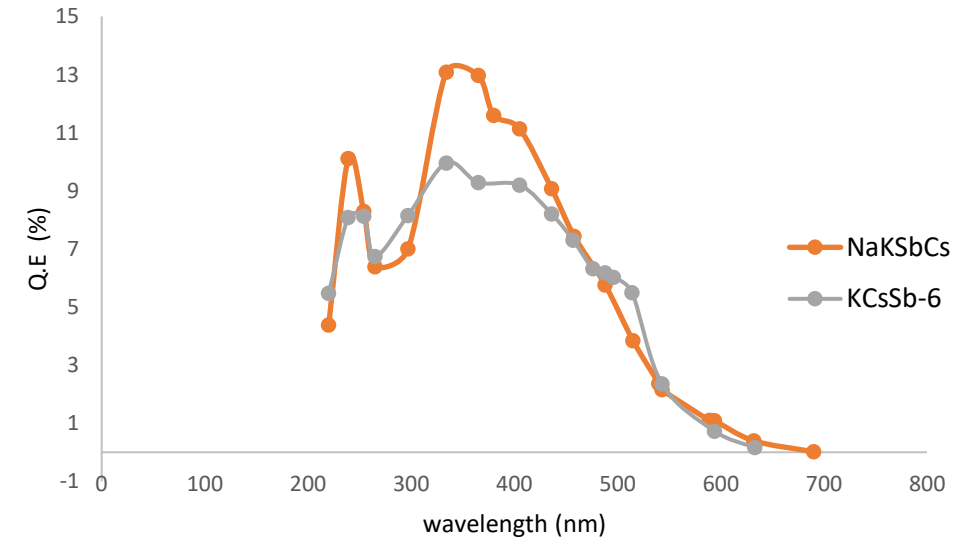
Procedure:

Sb -> K -> Na -> Sb -> K -> Na -> Sb -> Cs



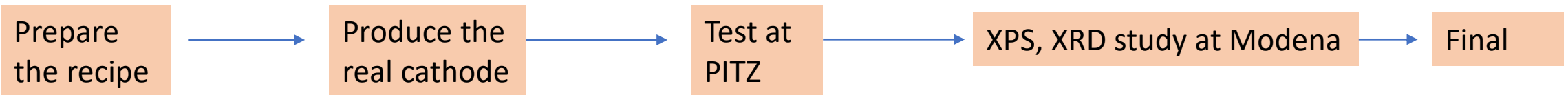
Layer up on layer or super lattice method

- NaKSb(Cs)-1 is partial successful with Q.E 2% @514 nm
- Layer up on layer procedure was successful.
- NaKSb(Cs)-2 with Q.E 3.9% @514 nm



Outlook

- KCSb photocathodes are reproducible with around 6% Q.E @514 nm and with 17 % Q.E threshold @ 297 nm.
- Further optimization is possible for KCSb cathode.
- Layer- up on layer could be try on KCSb photocathodes to improve Q.E.
- More optimization is needed for NaKSb(Cs).
- Develop an another kind of phtocathode i.e, Cs_3Sb Photocathode could be possible, since last part of NaKSb(Cs) cathode is similar.
- Prepare the new production chamber.
- Co-deposition procedure could be try.



KCSb, NaKSb(Cs),
Cs₃Sb

06-08-2020

Sandeep Mohanty | PITZ Physics seminar | Thesis update

New Cathode System

- The Green Cathode System parts acquisition is on going.
- The vacuum chamber has been fabricated, successfully leak check and Residual Gas Analyzer controlled.



- Major components already in house
 - Vacuum chamber
 - RGA
 - Vacuum probes and controller
 - Translators
 - Microbalance
 - Cathode heater and masking system
 - Bake out system (shared with Cs₂Te system) to be assembled
 - Some instrumentation can be shared with Cs₂Te system at the beginning and will have a stand-alone system

Vacuum chamber

Thanks!

• Backup Slides

Cathode type	Cathode	Typical wavelength & energy, λ_{opt} (nm), (eV)	Quantum efficiency (electrons per photon)	Vacuum for 1000 h (Torr)	Gap energy+ electron affinity, $E_G + E_A$ (eV)	Thermal emittance (microns/mm(rms))	
						Eq. (7)	Expt.
PEA: mono-alkali	Cs ₂ Te	211, 5.88 264, 4.70 262, 4.73	0.1 –	10 ⁻⁹ –	3.5 [42] “ “	1.2 0.9 0.9	0.5 ± 0.1 [35] 0.7 ± 0.1 [35] 1.2 ± 0.1 [43]
	Cs ₃ Sb	432, 2.87	0.15	?	1.6+0.45 [42]	0.7	?
	K ₃ Sb	400, 3.10	0.07	?	1.1+1.6 [42]	0.5	?
	Na ₃ Sb	330, 3.76	0.02	?	1.1+2.44 [42]	0.4	?
	Li ₃ Sb	295, 4.20	0.0001	?	?	?	?
PEA: multi-alkali	Na ₂ K ₃ Sb	330, 3.76	0.1	10 ⁻¹⁰	1+1 [42]	1.1	?
	(Cs)Na ₃ K ₃ Sb	390, 3.18	0.2	10 ⁻¹⁰	1+0.55 [42]	1.5	?
	K ₂ CsSb	543, 2.28	0.1	10 ⁻¹⁰	1+1.1 [42]	0.4	?
NEA	K ₂ CsSb(O)	543, 2.28	0.1	10 ⁻¹⁰	1+ < 1.1[42]	~0.4	?
	GaAs(Cs,F)	532, 2.33 860, 1.44	0.1 0.1	? ?	1.4 ± 0.1[42]	0.8 0.2	0.44 ± 0.01[44] 0.22 ± 0.01[44]
	GaN(Cs)	260, 4.77	0.1	?	1.96+?[44]	1.35	1.35 ± 0.1[45]
	GaAs(1-x)Px x~0.45 (Cs,F)	532, 2.33	0.1	?	1.96+?[44]	0.49	0.44 ± 0.1[44]
	S-1	Ag-O-Cs	900, 1.38	0.01	?	0.7[42]	0.7

D.H. Dowell et al. / Nuclear Instruments and Methods in Physics Research A 622 (2010) 685–697